

Docket No. 203424US0X PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICATION OF: Pascale MOTTE, et al.

SERIAL NO: 09/786,059

GAU: 1762

FILED: June 13, 2001

EXAMINER: CHEN, B.

FOR: METHOD FOR DEPOSITING A SILICON-CONTAINING DIELECTRIC MATERIAL ON COPPER

REQUEST FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

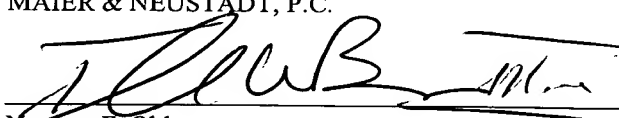
It is hereby requested that a three month extension of time be granted to May 25, 2003 for

- ☒ filing a response to the Official Action dated: November 25, 2002.
- ☐ responding to the requirements in the Notice of Allowability dated:
- ☐ filing the Formal Drawings. The Issue Fee due has been timely filed.
- ☐ responding to the Notice to File Missing Parts of Application dated:
- ☐ filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
- ☐ filing an Appeal Brief. A Notice of Appeal was filed on:
- ☐ Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.

The required fee of \$930.00 is enclosed herewith by check and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.


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